



**ELECTRONIC COPY**

LG669434312  
Report verification at igi.org



December 14, 2024

IGI Report Number **LG669434312**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**

Measurements **9.03 X 6.28 X 4.11 MM**

**GRADING RESULTS**

Carat Weight **2.09 CARATS**

Color Grade **D**

Clarity Grade **VS 1**

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MODIFIED BRILLIANT**

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Color Grade **D**

Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**

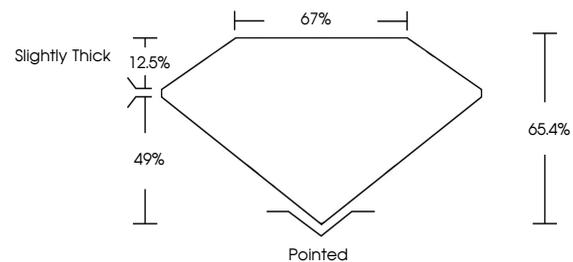
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG669434312**

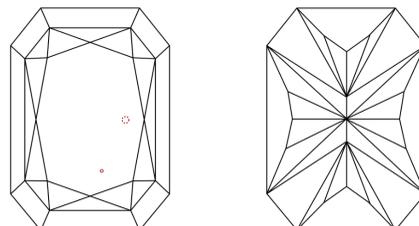
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

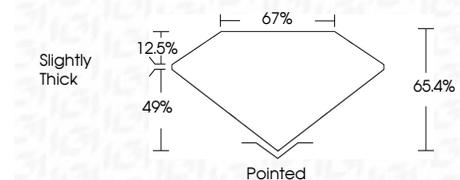
**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

IF WS<sup>1-2</sup> VS<sup>1-2</sup> SI<sup>1-2</sup> I<sup>1-3</sup>

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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**IGI**



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CUT CORNERED RECT. MODIFIED BRILLIANT

9.03 X 6.28 X 4.11 MM

2.09 CARATS  
D

Color Grade  
D

Clarity Grade  
VS 1

Depth  
65.4%

Table  
67%

Girdle  
Slightly Thick

Culet  
Pointed

Polish  
EXCELLENT

Symmetry  
EXCELLENT

Fluorescence  
NONE

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